

DIGITAL-TO-ANALOG BEAM ENERGY AND CURRENT STABILIZATION OF ELV ELECTRON ACCELERATORS

BUDKER INSTITUTE OF NUCLEAR PHYSICS, SB RAS, NOVOSIBIRSK, RUSSIA

ELV industrial electron beam accelerator is effective instrument for radiation treatment applications. Especially frequently it is used in cable and heat shrink tube manufacturing. Accelerator is only a part of technology line. There are underbeam transportation line, take-up and pay-off systems, safety system etc... All of them are controlled by signals from ELV control system, which are generated on base of the values as electron energy and beam current. There are 2 well-known methods of controlling the transportation line. The first: there ELV is master, line is slave (see Fig. 1). What things are the most important for this method?

For accelerator:
-stable parameters (better stability – less inhomogeneity of absorbed dose);
-smooth beam operation (fast beam current changes can break treated cable or tube).

For technology line:
-quick response for incoming parameters changes;

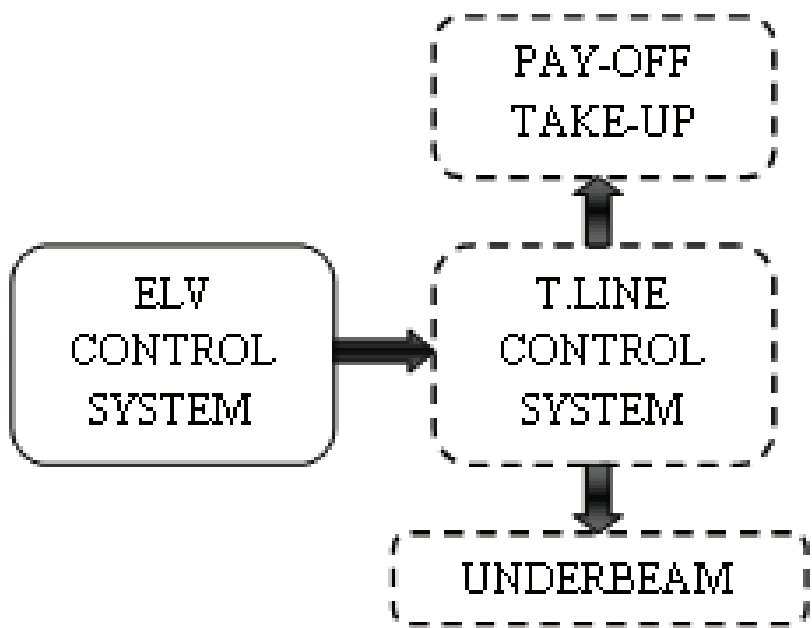


Figure 1: Accelerator is master.

Other method, where the accelerator is a slave, the technology line is a master, and accelerator parameters (beam current) follow production line velocity (see Fig. 2). Unlike the first method, here the most important things will be:

For accelerator:
-stable parameters (better stability – less inhomogeneity of absorbed dose);
-quick response for incoming parameters changes;

For technology line:
-smooth velocity;

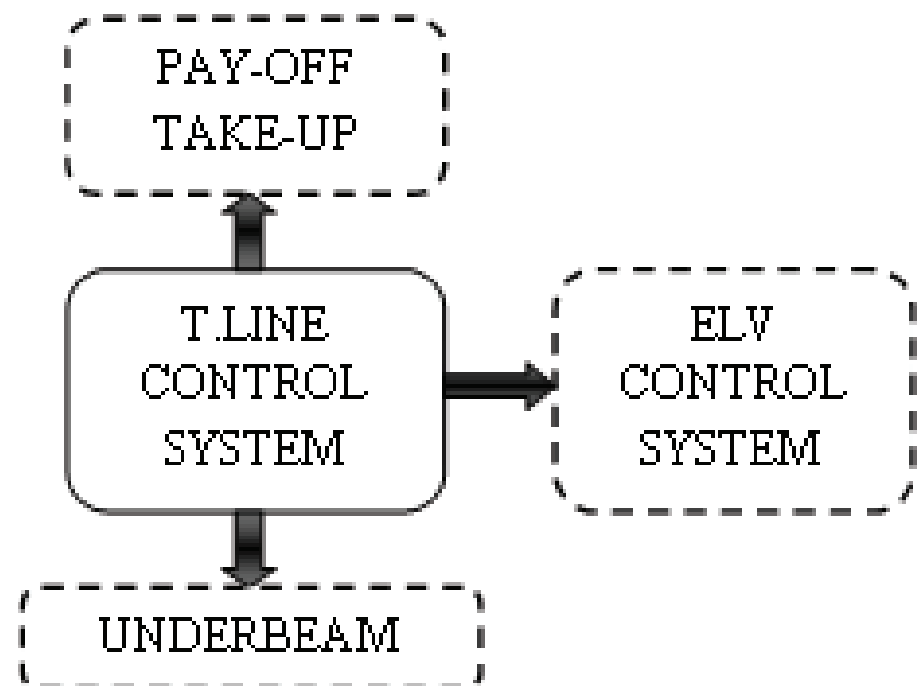


Figure 2: Accelerator is slave.

New technologies of rubber component irradiation treatment are increasing the performance of technology lines, so they are using second method of links the accelerator to technology line. It led us to find possibility to increase the velocity of beam current control (speed of ascending/descending of beam current value).

$$E = E_{ref} - V_{bc} * k \quad (1)$$

E_{req} – requested energy, MeV
 V_{bc} – beam current velocity, mA/sec
 k – coefficient, MeV/mA/sec

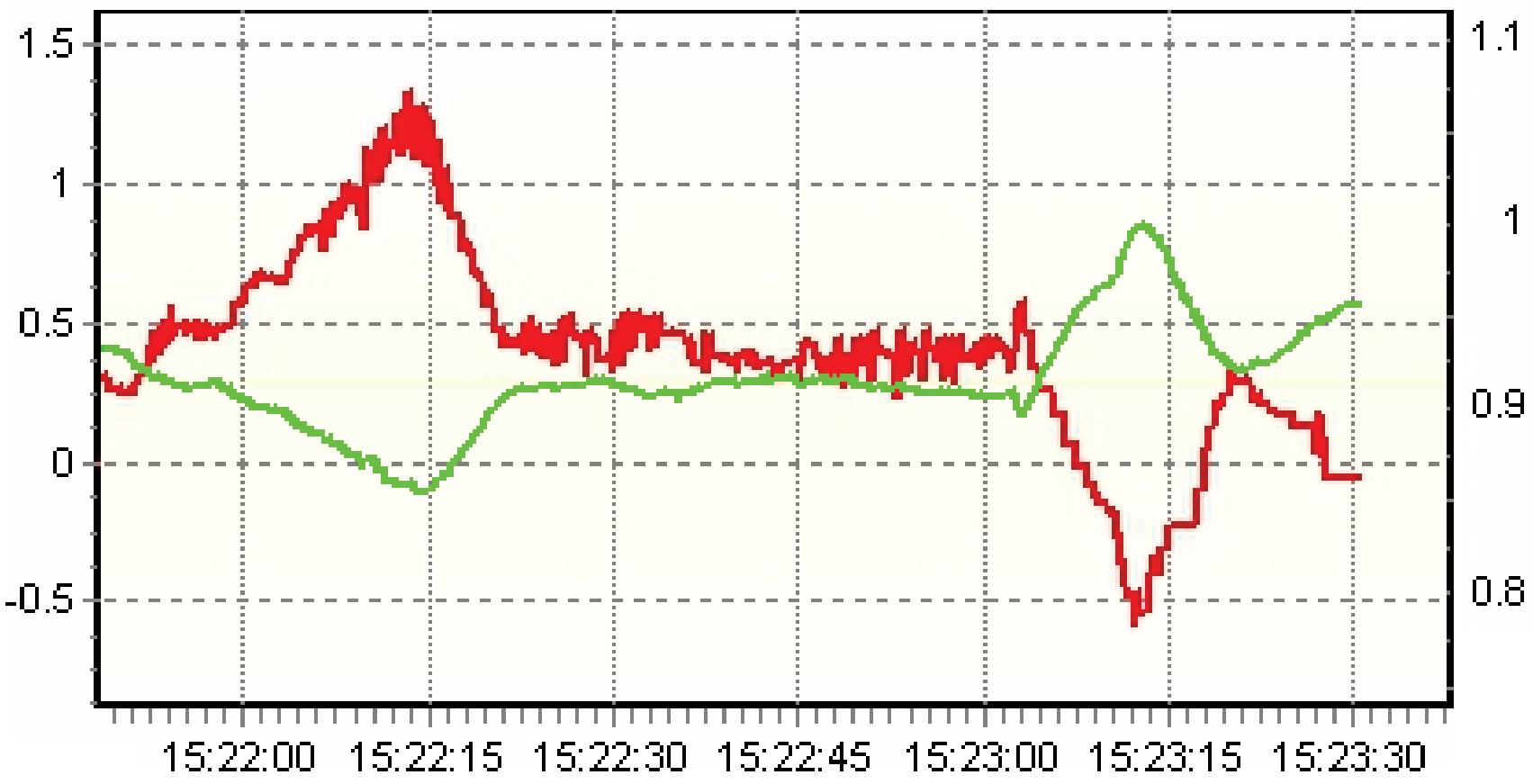


Figure 3: Energy (green line, right scale, MeV) and current velocity (red, left scale, mA/sec) curves.

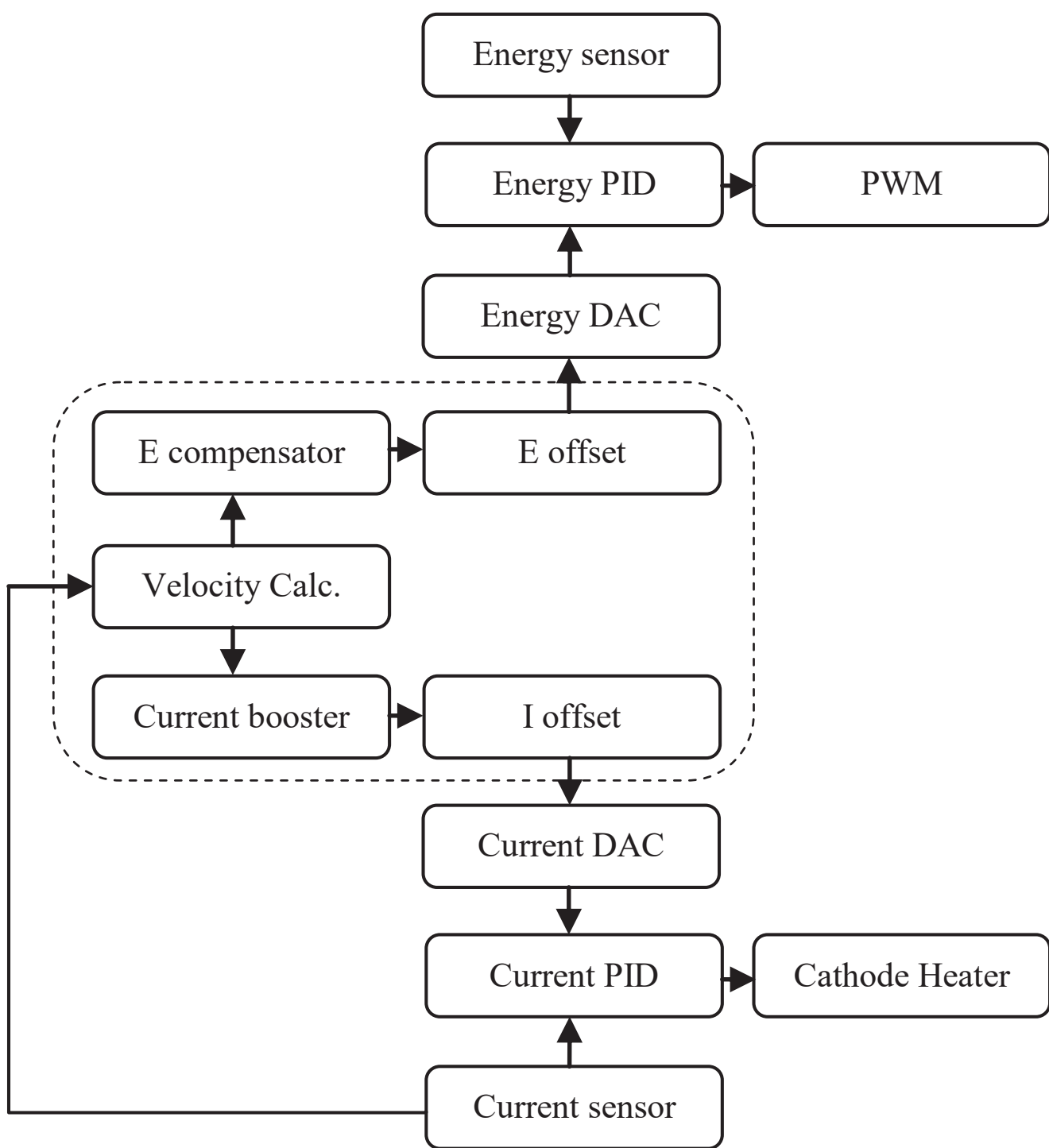


Figure 4: Schematic diagram of stabilization systems.

$$DAC_{current} = I_{offset} * \left(\frac{Current\ point}{End\ point} \right)^2 + I_{ref}$$

I_{offset} – beam current offset
 I_{ref} – reference beam current
Current and end points – current and final beam current value

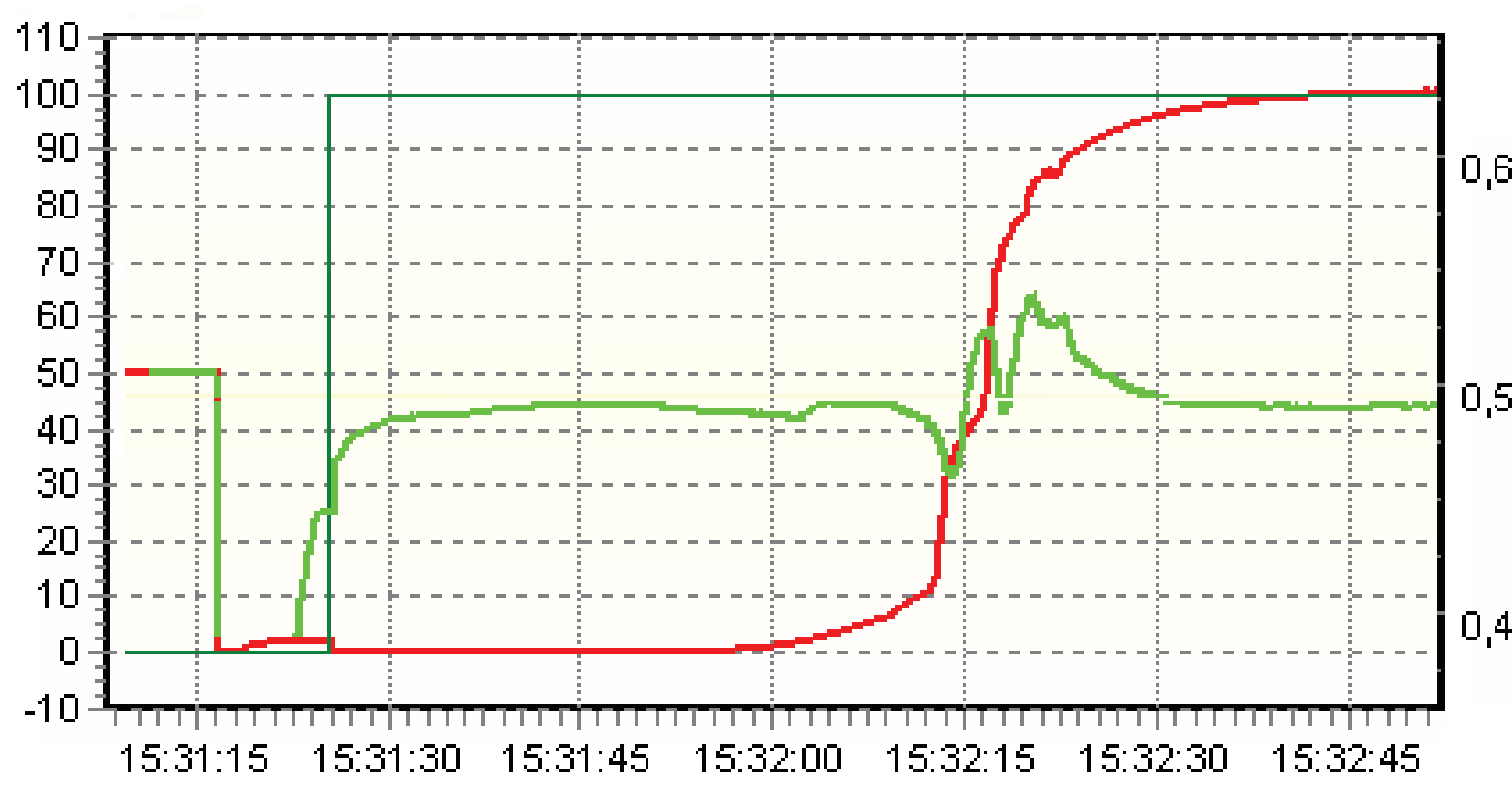


Figure 5: Energy (green line, right scale, MeV) and beam current (red, left scale, mA), ultra-fast rising.

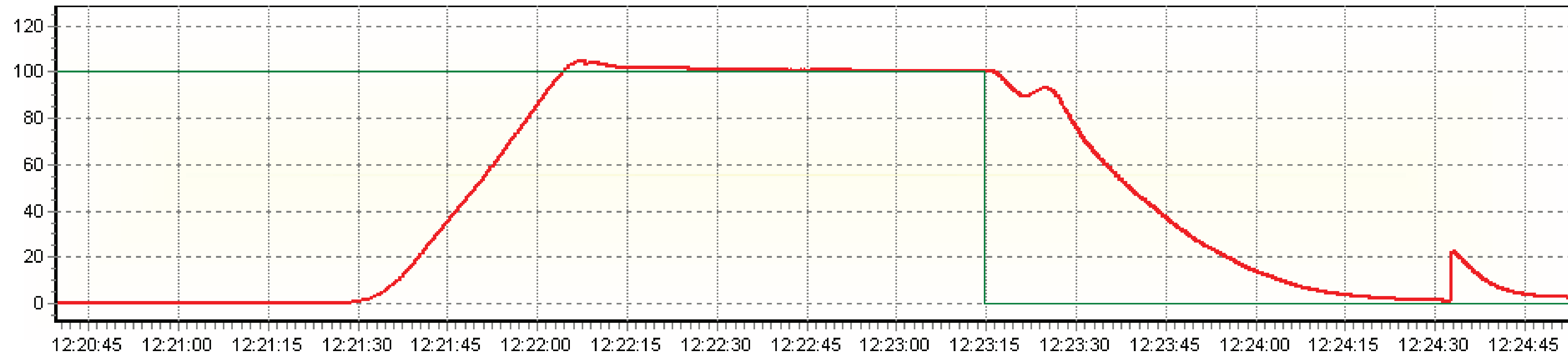


Figure 6: Beam current (red line), mA. Parameters was recorded on accelerator ELV-0.5 (0.5 MeV, 100 mA). Rising time ~30 sec.



Figure 7: Accelerator ELV-0.5, and technology line in Qingzhou, China.

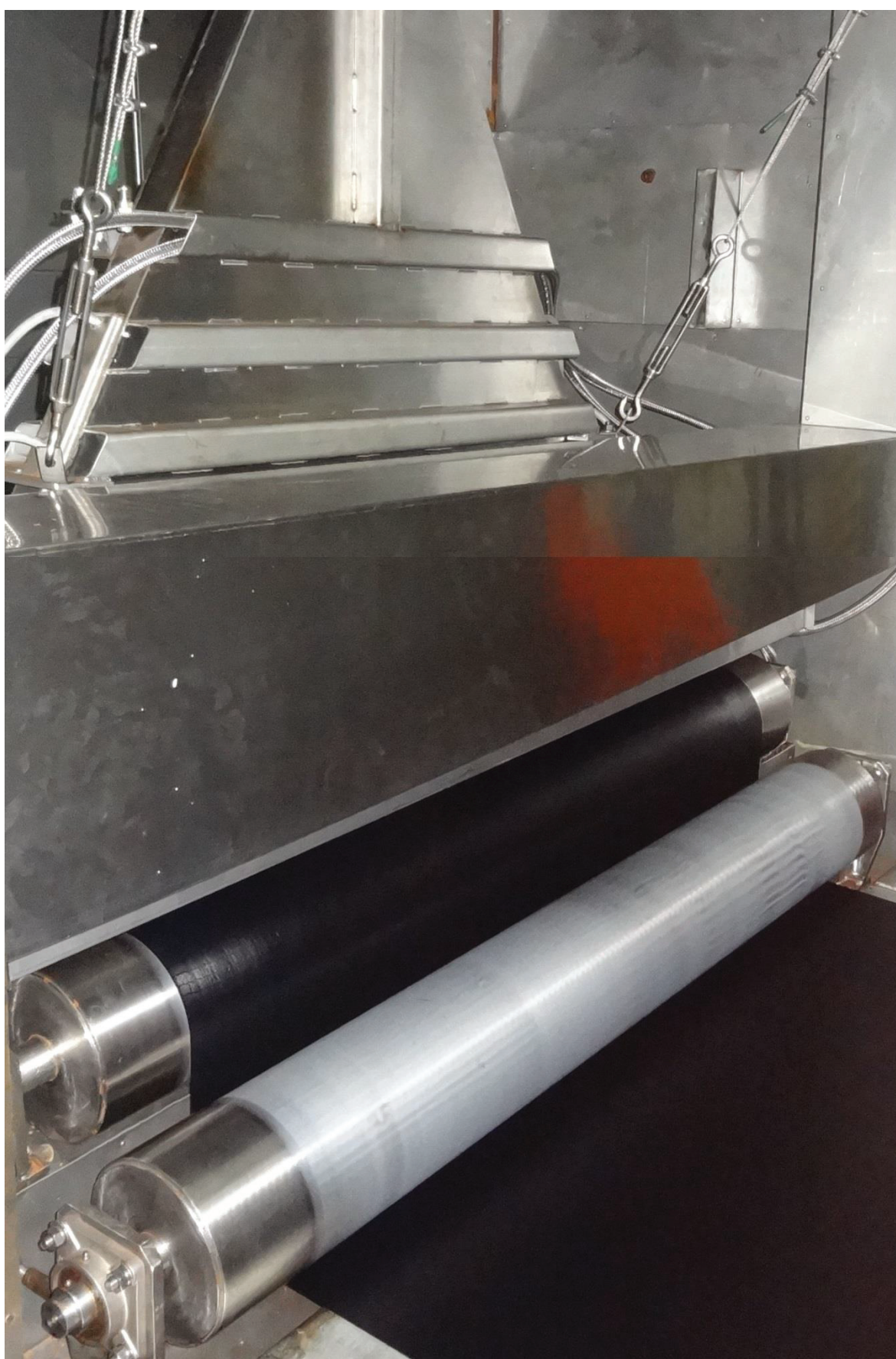


Figure 8: Production under extraction device.